

JFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813  
Examiner: Jack S. J. Chen

In Re PATENT APPLICATION of:

Applicant(s): Toshikazu MIZUKOSHI )

Serial No.: 10/635,506 )

Filed: August 7, 2003 )

For: METHOD OF FABRICATING A )  
SEMICONDUCTOR DEVICE TRENCH )  
HAVING AN OXIDE FILM ON A )  
CORNERED PORTION THEREOF )

**AMENDMENT**

Atty. Dkt.: OKI 361 )

June 27, 2005

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on April 20, 2005, please amend the above-identified application as follows:

FEE ENCLOSED:\$0  
Please charge any further  
fee to our Deposit Account  
No. 18-0002